Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/667,711	STARZEWSKI ET AL.		
Examiner	Art Unit		
Caixia Lu	1713		

SEARCHED				
Class	Subclass	Date	Examiner	
526	160° 165 348 903 161	8-10-06	a	
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOT (INCLUDING SEARCH :	ES STRATEGY)
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